1/6 Cyril Cabral Jr. et al. MU Y0999-408 CIP 6B SOI SOURCE  $\mathsf{t}_{\mathsf{si}}$ DRAIN 2 BURIED OXIDE SUBSTRATE FIG.1 100 CO DEPOSITION SOI SOURCE DRAIN tsi BURIED OXIDE SUBSTRATE

FIG.2

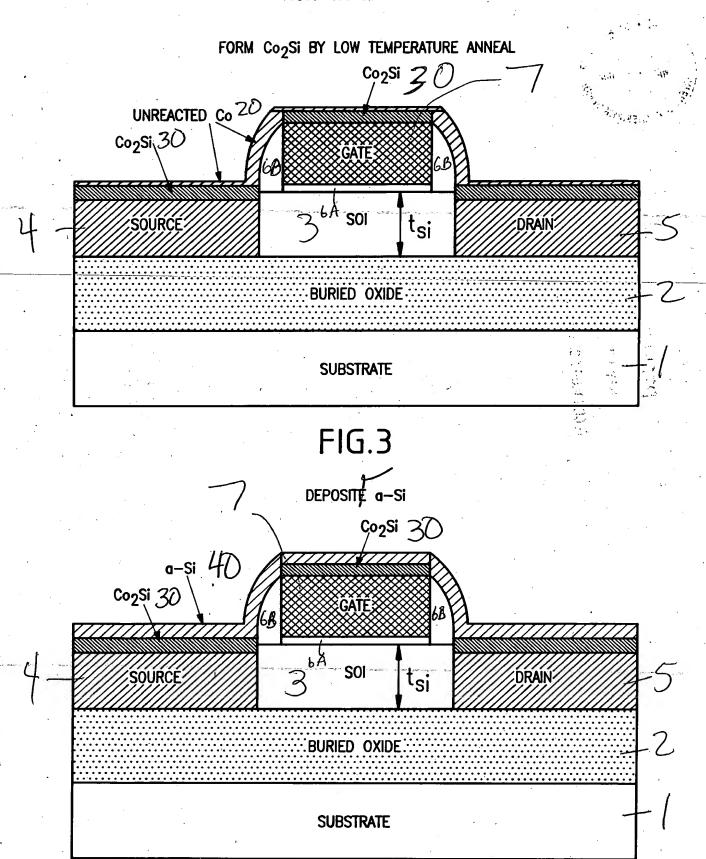


FIG.4

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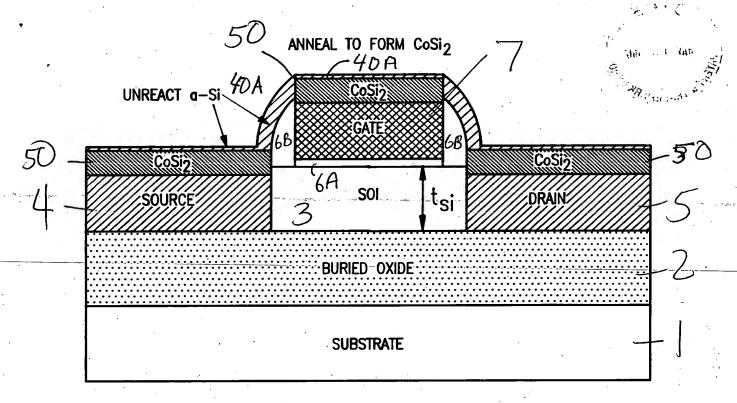


FIG.5

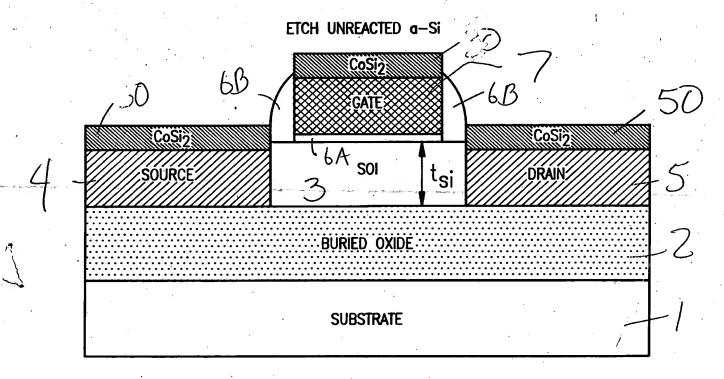


FIG.6